

**Electron-Beam Lithography System Job Form**  
**University of Central Florida - College of Optics and Photonics - CREOL**

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Date:                      Job log file number:                      User name:

Budget or Fund number:                      Group affiliation:

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**Finance Charges Information**

Total writing time (in min.):                      Job done for:

UCF	Industry
Government	Academic (non-UCF)

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Charge rate (\$ per min):                      First hour flat rate:                      Additional charges:

Time after 60 min (min):                      Charge after 60 min:                      24 h charge limit reached:  
(flat rate applied)

Initial fee (if applicable):                      Total amount:                      Mask writing:  
(flat rate applied)

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Signature:    Comments: